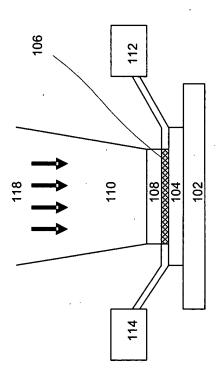
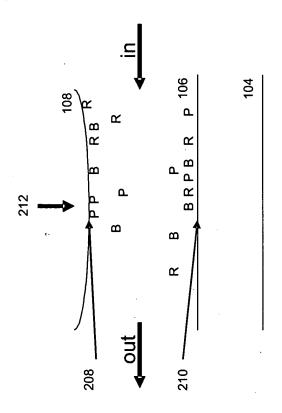
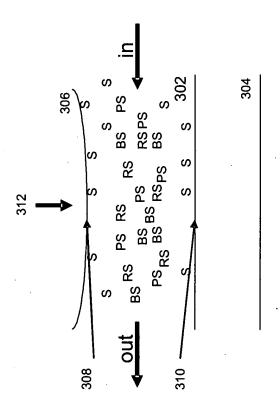
U.S. Patent Appln: METHOD AND SYSTEM FOR IMMERSION LITHOGRAPHY LENS CLEANING Inventors: Ching-Yu Chang and Chin-Hsiang Lin Attorney Docket No.: N1280-00290(TSMC2003-1435) Page 1 of 5







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